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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masahiro YOSHIKAWA

Group Art Unit: 2828

Application No.: 10/629,777

Filed: July 30, 2003

Docket No.: 116722

For: METHOD OF FORMING CONDUCTIVE PATTERN SUCH AS ELECTRODE,
SURFACE EMITTING SEMICONDUCTOR LASER USING THIS METHOD AND
MANUFACTURING METHOD FOR THE SAME

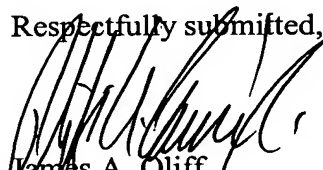
STATUS INQUIRY LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please telephone our firm's Patent Application Filing Department at 703-836-6400 with the status of the above-identified patent application, including an indication as to when the next communication can be expected.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

Philip A. Caramanica, Jr.
Registration No. 51,528

JAO:PAC/mlo

Date: May 12, 2005

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400